



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit 2814

Examiner: Hoa B. Trinh

I hereby certify that this document is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 6, 2004.

Enrique Pérez

For: METHOD AND APPARATUS FOR FORMING A THIN SEMICONDUCTOR FILM, METHOD AND APPARATUS FOR PRODUCING A SEMICONDUCTOR DEVICE, AND ELECTRO-OPTICAL APPARATUS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Sir:

This Amendment is filed in response to the Office Action of May 7, 2004. Please reconsider the application in view of the amendment and remarks presented below.